## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Multiple sheets used when necessary)
SHEET 1 OF 1

|  | DOCUMENTS |
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|  |           |

| Examiner<br>Initials | Cite<br>No. | Document Number<br>Number - Kind Code (if known)<br>Example: 1,234,567 B1 | Publication Date<br>MM-DD-YYYY | Name of Patentee or Applicant | Pages, Columns, Lines Where<br>Relevant Passages or Relevant<br>Figures Appear |
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|                      | 1           | 3,660,179   | 05-02-1972                     | Desmond et al                 |  |
|                      | 2           | 5,458,733   | 10-17-1995                     | Tessmer et al.                |  |
|                      | 3           | 6,426,273   | 07-30-2002                     | Toshiharu Yanagida            |  |
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| Examiner<br>Initials | Cite<br>No. | Foreign Patent Document<br>Country Code-Number-Kind Code<br>Example: JP 1234567 A1 | Publication Date<br>MM-DD-YYYY | Name of Patentee or Applicant | Pages, Columns, Lines Where<br>Relevant Passages or Relevant<br>Figures Appear | T¹ |
|                      | 6           | WO 00/63957  | 10-26-2000                     | Genitech, Inc.                |  |    |

## NON DATENT LITEDATURE DOCUMENTS

|  | NON PATENT LITERATURE DOCUMENTS |  |  |  |
|--|---------------------------------|--|--|--|
| Examiner Initials No. Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the litem (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. |                                 | T <sup>1</sup>   |  |  |
|  | 7                               | CATHERINE et al., Plasma Deposition of Aluminum Oxide Films, J. Elec. Mat., 1988, Vol. 17 (2), Pages 127-134                   |  |  |
|  | 8                               | EHLE et al., Low Temperature Aluminum Oxide Deposition Using Trimethylaluminum, J. Elec. Mat., 1982. Vol. 12(3). Pages 587-601 |  |  |

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Examiner Signature

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\*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.